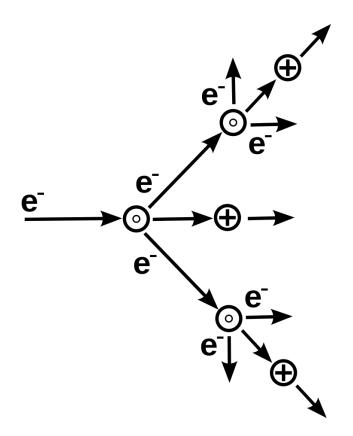
## James Amidei

# Langmuir Probe Experiment



# Theory

- Plasma is an ionized gas that is composed of dissociated electrons and ions.
- Plasma is described in terms of macroscopic "plasma parameters", including electron and ion temperature and density, and plasma potential.
- A Langmuir probe is a measurement device which is used to measure the plasma parameters in low temperature plasmas.
- By generating a plasma in a vacuum tube (<1 Torr), we are able to use a Langmuir probe to measure the I-V curve and derive the electron temperature, plasma potential, and floating potential.

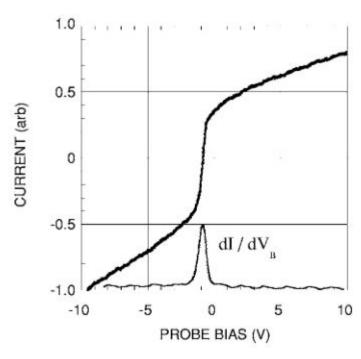


Figure 1. I-V curve with dI/dV plotted with respect to V to show the value of plasma potential.

### Instrumentation

- The probe's bias potential was set by the Keithley 6487 picoammeter/voltage source.
- The 6487 is a feedback picoammeter; a design that reduces the voltage burden by several orders of magnitude, resulting in behavior much more like that of an ideal ammeter than a more traditional shunt picoammeter.
- The 6487 was used to perform a sweep across a set voltage range, as well as to measure the current generated by the plasma.
- Stability of measurement is maintained by a process called "autozeroing", where the 6487 measures its own internal voltages, which are then used in the algorithm to calculate the reading of the input signal.
- The 6487 is connected to a computer and controlled using a python script with which the voltage range of the sweep can be set.

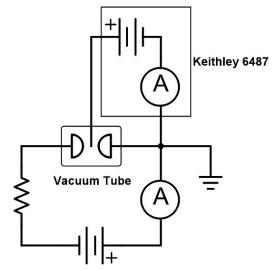


Figure 2. Diagram of experimental setup.

High Voltage Power Supply

Figure 3. Keithley 6487



# Data Analysis

- Data was taken for three voltages across the plasma: 1200 V, 1300 V, and 1400 V.
  - For each voltage, the probe bias was swept over the range -450 V to -120V.
- Once the data was collected, the I-V curve was plotted.
  - With the I-V curve, the ion saturation current, the electron saturation current, and the floating potential were found.
  - The gradient of the total current with respect to the voltage was plotted to find the plasma potential.
- The ion saturation current was subtracted from the total current in the I-V curve, and the natural log of the remaining electron current was plotted.
- The linear range of the log of the electron current was selected and fit with a linear fit function.
  - The slope of the linear fit was used to determine the electron temperature.

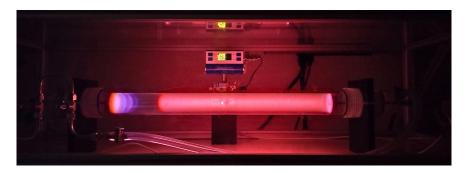
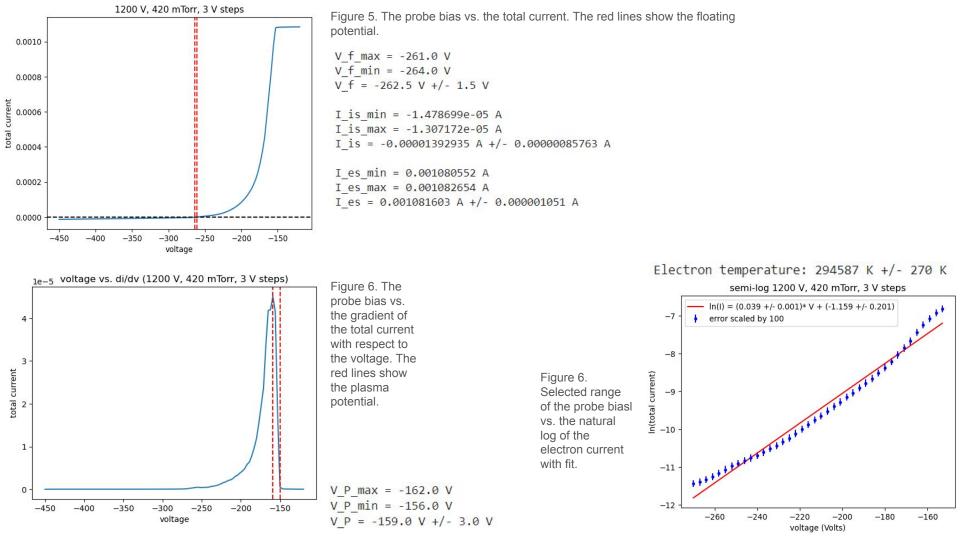


Figure 4. Plcture of plasma generated in low pressure tube.

$$I_e(V_P) = I_{es} e^{\frac{-q_e(V_P - V_B)}{kT_e}}$$

$$ln(I_e) = \frac{q_e V_B}{kT_e} - \frac{q_e V_P}{kT_e} + ln(V_{es}) = \frac{q_e V_B}{kT_e} + b$$



# Langmuir probe in atmospheric measurements

- Langmuir probes are used take in situ measurements of plasma parameters in the atmosphere.
- Monitoring the plasma parameters in the upper atmosphere helps to predict geomagnetic storms and ionospheric disturbances which can affect radio and satellite communications.
- The critical frequency f\_c of a plasma is proportional to the maximum electron density.
  - Radio waves with a frequency less that the ionospheric plasma's f c will be reflected back towards the Earth.
  - Radio waves with frequencies greater than f\_c will penetrate the ionospheric plasma and be scattered.
- This makes the electron density in particular an important plasma parameter to understand when attempting to communicate via radio wave signal.
- The electron density can be derived from the I-V curve measured by the Langmuir probe.

$$I_{es} = \frac{1}{4} e n_e v_e A_{probe} = e n_e \left( \frac{kT_e}{2\pi m_e} \right)^{1/2} A_{probe}$$

$$n_e = eI_{es} \left(\frac{kT_e}{2\pi m_e}\right)^{1/2} A_{probe}$$

$$f_c = 9\sqrt{n_{e,max}}$$

(critical frequency in terms of the maximum electron density)

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